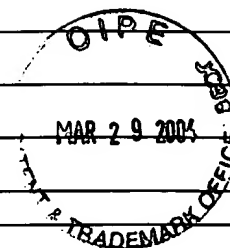


INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.2306	Appln. No.	09/559,757
Applicant	Yoshio Ozawa, et al.		
Filing Date	April 27, 2000	Group:	2823



U.S. PATENT DOCUMENTS

Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
	8-250720	09/1996	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce



Single

2823
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PATENT
Customer No. 22,852
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshio Ozawa, et al.) Group Art Unit: 2823
Application No.: 09/559,757) Examiner: Pham, Thanh V.
Filed: April 27, 2000)
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE)
USING AN OXIDATION)
PROCESS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97(d)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(d), Applicants bring to the attention of the Examiner the documents listed on the attached PTO-1449 form. Applicants file this Information Disclosure Statement (IDS) after issuance of a Final action, and therefore enclose a fee of \$180.00 as specified under § 1.17(p), and a certification as specified under § 1.97(e)(1). This IDS supplements the IDS filed April 27, 2000.

Applicants attach a copy of the listed document. Applicants respectfully request that the Examiner consider the listed document and indicate its consideration by making appropriate notation on the attached PTO-1449 form.

As evidenced by the mailing date listed on the English language translation of the attached Japanese Patent Office Action, Applicants submit that the document listed in this IDS

was first cited in that Japanese Patent Office Action in a counterpart foreign application on February 17, 2004, which is not more than three months prior to the filing of this IDS.

In lieu of a statement of relevance or full translation of the non-English document, Applicants enclose an English language version of the attached Japanese Patent Office Action, entitled "Notification of Reasons for Rejection," mailed on February 17, 2004, in a counterpart Japanese application, citing and setting forth the relevance of the attached document.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "prior art." If the Examiner applies the document as prior art against any claims in the application and Applicants determine that the cited document does not constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the document.

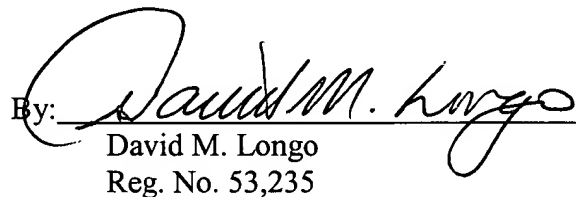
Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: March 29, 2004

By: 
David M. Longo
Reg. No. 53,235